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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Mehrdad Nikoonahad
Title: Overlay Error Detection
Application No.: 09/697,025
Filing Date: 10/26/2000
Conf. No.: 3437
Docket No.: TNCR.183US0

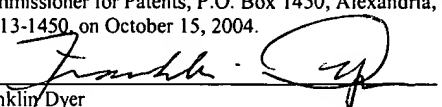
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

COMMUNICATION


Dear Sir:

An Information Disclosure Statement was mailed to the United States Patent and Trademark Office on April 4, 2001, and is listed as filed at the United States Patent and Trademark Office on April 9, 2001 in PAIR.

It is respectfully requested that this Information Disclosure Statement together with the PTO form 1449 and references be reviewed and made of record in the above-identified application. A courtesy copy of this Information Disclosure Statement together with the PTO form 1449 are enclosed for the Examiner's convenience.

Certificate of Mailing Under 37 CFR 1.8
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 15, 2004.

Franklin Dyer

Respectfully submitted,


James S. Hsue
Reg. No. 29,545

10/15/04
Date



COPY

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): MEHRDAD NIKOONAHAD, GUOHENG ZHAO, ANDREI V. SHCHEGROV and BEN TSAI
Assignee: KLA-TENCOR TECHNOLOGIES CORPORATION
Title: OVERLAY ERROR DETECTION
Serial No.: 09/697,025 Filing Date: October 26, 2000
Examiner: Unknown Group Art Unit: 2623
Docket No.: M-10697 US

San Jose, California
April 4 2001

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants wish to call the enclosed documents to the attention of the Examiner. A PTO form 1449 listing these documents is enclosed.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on APR 4, 2001.

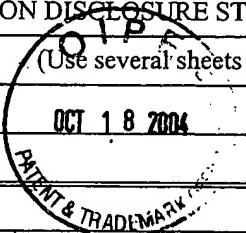
Tammy L. Kaplan 4/4/01
Tammy L. Kaplan Date of Signature

Respectfully submitted,

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U.S. Department of Commerce, Patent and Trademark Office					Atty Docket No.		Serial No.	
					M-10697 US		09/697,025	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)			
(Use several sheets if necessary)					MEHRDAD NIKOONAHAD ET AL.			
					Filing Date		Group	
					October 26, 2000		2623	
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,023,338	2/8/2000	Bareket	356	401	7/12/96	
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AQ	"Microinterferometre differentiel a ondes polarises," G. Nomarski, <i>J. Phys Radium</i> 16, (S-13S (1955)						
	AR	"Lithography Process Control," H. Levinson, <i>SPIE press</i> , Vol. TT28, Bellingham, Washington, 1999						
	AS							
Examiner			Date Considered					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</p>								

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